Page 1 of 3
Title: METHOD OF MANUFACTURING SEMICONDUCTOR MEMORY WITH DEUTERATED MATERIALS

Inventors: Tazrien Kamal, et al.

Docket No.: AF01139.D1

Contact: Mikio Ishimaru (408) 738-0592

1/3

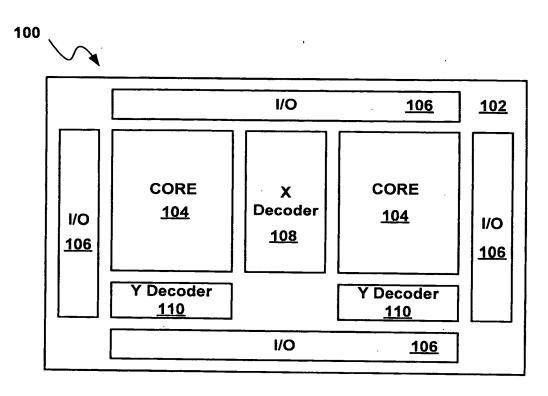


FIG. 1

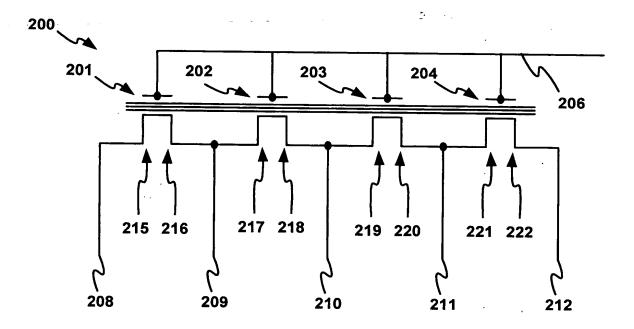


FIG. 2

Page 2 of 3

Title: METHOD OF MANUFACTURING SEMICONDUCTOR MEMORY WITH DEUTERATED MATERIALS

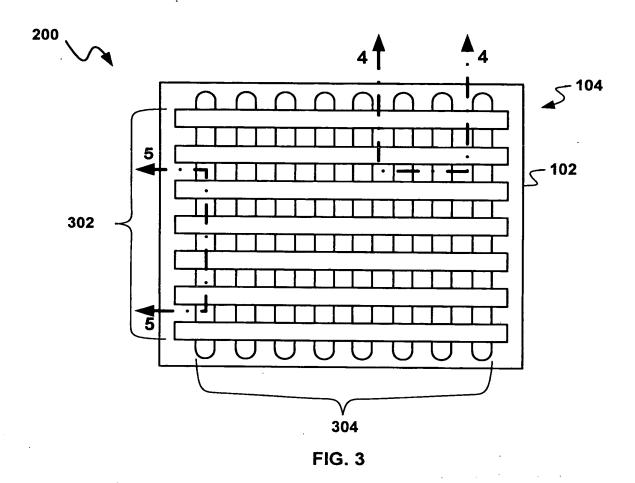
Topics Karpel et al.

Inventors: Tazrien Kamal, et al.

Docket No.: AF01139.D1

Contact: Mikio Ishimaru (408) 738-0592

2/3



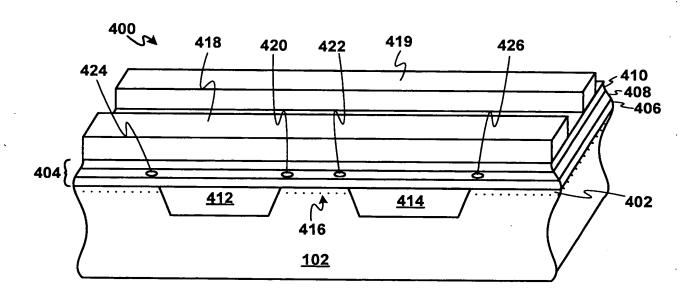


FIG. 4

Päge 3 of 3
Title: METHOD OF MANUFACTURING SEMICONDUCTOR MEMORY WITH DEUTERATED MATERIALS

Inventors: Tazrien Kamal, et al.

Docket No.: AF01139.D1 (408) 738-0592 Contact: Mikio Ishimaru

3/3

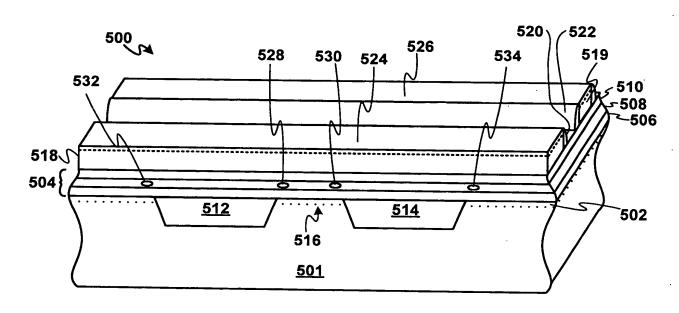


FIG. 5

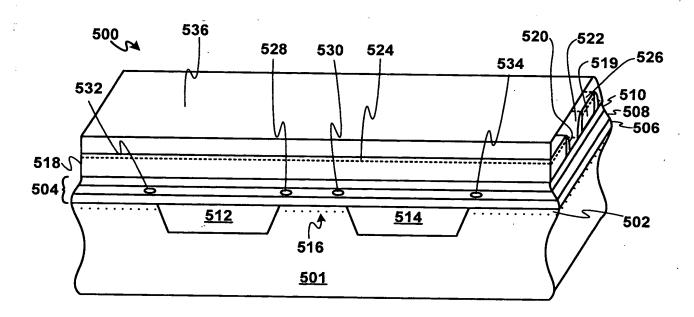


FIG. 6